

Tmetrics C20 3D Super EDF Microscope Camera

A smart camera that can directly obtain microscopic 3D images and measure them, upgrading your microscope's observation and analysis competence!



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- Easy to use: No computer required, perform 3D observation and measurement.
- Wide applications: Equip with metallographic, stereo and other reflective microscopes.
- Accuracy measurement: ±2um measuring accuracy for 2D&3D with 10x objective lens.



The C20 camera integrates features of high integration and flexibility, it can be directly used on reflective microscopes without any additional modification, the operation is easy to be done and all functions can be completed via mouse. Its built-in core technology can offer strong smart linkage performance guarantee for microscopic system: built-in intelligent heterogeneous host can replace computer to carry out plenty of calculating works directly, and the operation is speedy and stable. Real-time super depth of field and 3D moulding algorithm can contribute microscopic system to achieve comprehensive three-dimensional observation and measurement analysis. Meanwhile, the automatically edge recognition algorithm can also further improve the efficiency of microscopic observation and batch operation.

A Heterogeneous system

Possess ability for high speed data calculation



- Three computing algorithms
 - · Super depth of field
 - · 3D moulding
 - Edge recognition

Four in one systems

High-speed camera

Imaging analysis software

Z-axis motorize stage



High-performance host



Upgrading your microscope's capability







3D measurement



2D auto measurement





Super depth of field to get all features on the same plane

Open "Capture-Advanced imaging-EDF&3D" function module in the software, confirm the position of the upper and lower focal planes to be observed in the image via mouse, click "EDF", then the C20 will automatically fulfill the depth of field, show all features on the image.



Real-time EDF for clear microscopic observation

Ordinary microscopes cannot focus on multiple layers at the same time under high magnification. It is easy to cause angle deviation, rotation and uneven focal plane by using third party software and hardware systems to expand the depth of field. The C20 inner smart EDF algorithm can help solve these problems, capture a clear and correct full-frame focusing image.



The EDF image of third SW and HW system



The EDF image of C20

Real-time WDR to eliminate strong reflection

Strong reflections on the metal surface may lead to misjudgment of details. The C20 provide its WDR function to capture the perfect exposed images by calculating data in real time from multiple images of different brightness levels.



Before WDR



After WDR

Open "Capture-Advanced imaging-EDF&3D" function module in the software, confirm the position of the upper And lower focal planes to be observed in the image via mouse, and click "3D", then C20 will automatically complete 3D moulding. You can observe the real scene or pseudo-color model with 360° rotation.





The Real scene model



The pseudo-color model

Rich 3D Measurement functions

The C20 provides a wealth of 3D tools for easily measure any position of the 3D model and record the data in real time. With the metallographic microscope of 10 times objective lens, , the Z-axis measurement accuracy and repeatability is±2 micron and±1 micron. The higher magnification objective lens, and the higher precision data.

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The inner height measurement



Microscope: stereo Model: Clock gear Height: 5661mm

The precision structure analysis



Microscope: metallographic Model: sensor chip Height: 34062µm The C20 also features 2D intelligent image recognition to help you quickly set up the standard measurement pattern without manual precise positioning, and finish various batch measurement operations. With the stereo microscope of 2.5 times magnifying, the 2D automatic measurement accuracy and repeatability is ±5 micron and ±3 micron.

Quality judgment



For standard parts, C20 can automatically display OK/NG results of samples according to the set standard deviation range, improving the efficiency of quality detection.

Advanced Measuring
Advanced Measuring
Advanced Measuring
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Batch task



For non-standard parts, C20 can output the measurement data of all samples at one time by setting the similarity tolerance to improve the efficiency of batch tasks.

Report creation function of humanity

The C20 can not only save images and video data, but also automatically create test reports with pictures and texts, all 2D and 3D data in the work- flow all can be exported. The job was done when operation finished, easy and simple!

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Product specification

Model		Tmetrics C20		
	Sensor	Sony 1/2"color CMOS		
	Resolution	1080P(1920×1080)		
	Pixel size	3.75µm×3.75µm		
	Shutter mode	Rolling		
	Scanning method	Progressive scanning		
Camera Features	Frame rate	60fps(Normal),30fps(WDR)		
	Gain	Automatic / Manual		
	Exposure time	Automatic: 0.1ms-16.6ms, manual: 0.0001s-1s		
	White balance	Automatic/manual/area		
	Image storage	TIFF/JPEG		
	Video format	AVI/MP4(1080P)		
	3D noise reduction	Support		
	WDR	Support		
	Real-time EDF	Support		
Advanced Features	Edge enhancement	Support		
(Embedded)	Gamma correction (contrast)	Support		
	Color enhancement	Support		
	Flat field correction	Support		
	Effect mode	Normal/Negative/Relief/Grayscale		
	Online calibration	Support		
	3D display	Pseudo-color/real scene display, grid lines, 360°rotatio		
	3D histogram	Support		
	3D profile measurement	Height difference, curvature, area, roughness		
3D display and	3D surface measurement	Step height, volume, surface roughness		
measurement	Z range (depth of field, 10X)	230.00µm		
	3D measurement accuracy (10X)	±2μm		
	3D repeatability (10X)	±1μm		
	3D measurement report	Support, editable template		
	2D calibration ruler	Support		
	2D manual measurement	Point-point, point-line, line-line, Parallel, perpendicular, polygon, circle, arc, concentric circle, circle-circle, angle		
2D measurement	Counter	Manual		
	2D measurement accuracy (10X)	±2μm		
	2D repeatability (10X)	±2μm		
	2D measurement report	Support		
loout	Mouse input	USB mouse		
Input	Keyboard input	USB keyboard		
	Optics	Standard C-Mount		
late of a se	Video	HDMI 2.0		
Interface	Internet connection	Fast Ethernet		
	USB	USB2.0 x 3, USB3.0 x1		
	Storage capacity	Built-in 32G Emmc		
	Power supply	12V 8A		
Others	Weight	2.5kg		
	Appearance size (WxHxD)	87cm*181cm*103cm		
	Working environment	5°∈-40°⊂ (temperature), 45%-85% (humidity)		

Material section analysis



Surface trace detection



Biology observation



Component measurement









